

Applicant(s)	Xingwu Wang et al.	INFORMATION DISCLOSURE STATEMENT
Serial No.	Unknown	
Filing Date	Herewith	
Group Art Unit	Unknown	
Examiner	Unknown	
Attorney Docket No.	125.021US02	
Title: MAGNETIC THIN FILM INDUCTORS		

Mail Stop Patent Application
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

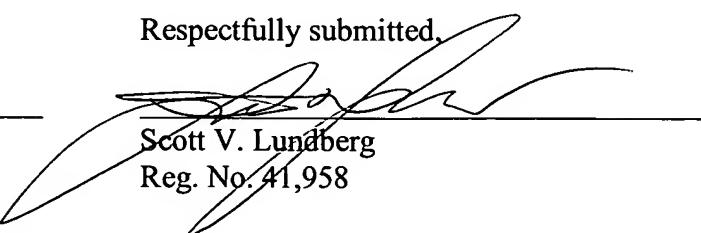
In compliance with 37 C.F.R. §§ 1.56 and 1.97, *et seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

Further pursuant to MPEP §609, because all of the references listed on the attached Form 1449 have been previously submitted and made of record in the parent application, U.S. Patent Application 10/014,045, filed December 11, 2001, copies of the references previously made of record in the parent application are not submitted herewith.

The Examiner is invited to contact the Applicant's Representative at the below-listed telephone number if there are any questions regarding this communication.

Respectfully submitted,

Date: 2-25-4


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U.S. Patent References				
Examiner Initials	Patent No.	Issue Date	Name	Filing Date
	5,370,766	12/06/94	Desaigoudar et al.	08/16/93
	5,450,263	09/12/95	Desaigoudar et al.	07/28/94
	5,609,946	03/11/97	Korman et al.	10/03/95
	5,635,892	06/03/97	Ashby et al.	12/06/94
	5,793,272	08/11/98	Burghartz et al.	08/23/96
	5,847,634	12/08/98	Korenivski et al.	07/30/97
	5,884,990	03/23/99	Burghartz et al.	10/14/97
	5,959,522	09/28/99	Andrews	02/03/98
	5,966,063	10/12/99	Sato et al.	08/19/96
	6,054,329	04/25/00	Burghartz et al.	10/14/97
	6,114,937	09/05/00	Burghartz et al.	10/14/97
	6,140,902	10/31/00	Yamasawa et al.	07/31/97
	6,175,293	01/16/01	Hasegawa et al.	05/11/93
	6,207,303	03/27/01	Tomita et al.	07/02/98
	6,262,649	07/17/01	Roessler et al.	09/30/97
	6,239,683	05/29/01	Roessler et al.	09/30/97
	6,489,876	12/03/02	Jitaru	09/22/00

Foreign Patent References				
Examiner Initials	Foreign Patent		Name	Publication Date
	Country	No.		
NONE				

Other References				
Examiner Initials	Author, Title, Date, Pages, etc.			
	G.G. Bush, The complex permeability of a high purity yttrium iron garnet (YIG) sputtered thin film, J. Appl. Phys. Vol. 73, pgs. 6310-6311(1993)			
	M. DeMarco, et al., Mossbauer and magnetization studies of nickel ferrites, J. Appl. Phys. Vol. 73 pgs. 6287- 6290 (1993)			
	S. Jin et al., High frequency properties of Fe-Cr-Ta-N soft magnetic films, Appl. Phys. Lett., Vol. 70, pgs. 3161-3163(1997)			
	V. Korenivski, and R.B. van Dover, Magnetic film inductors for radio frequency applications, J. Appl. Phys., Vol. 82, pgs. 5247- 5254 (1997).			
	M. Senda, et al., High frequency measurement technique for patterned soft magnetic film permeability with magnetic film/conductor/magnetic film inductance line. Rev. Sci. Instrum., Vol. 64, Pgs. 1034 - 1037 (1993)			
	M. Yamaguchi, et al., Characteristics and analysis of a thin film inductor with closed magnetic circuit structure, IEEE Trans. Magnetics, Vol. 28, pgs. 3015-3017 (1992).			
	M. Yamaguchi, et al., Magnetic RF integrated thin-film inductors, IEEE MTT-S International Microwave Symposium Digest, Vol. 1, Pgs. 205-208 (2000).			

Examiner Signature		Date Considered
<small>*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>		

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	M. Yamaguchi et al., Microfabrication and characteristics of magnetic thin-film inductors in the ultrahigh frequency region, J. Appl. Phys., Vol. 85, pgs. 7919-7922 (1999).
	S.X. Wang, et al., Properties of a new soft magnetic material, Nature, Vol. 407, Pgs. 150-151 (2000).

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